

4 / Priority
Claim
E. Willis
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: ITABASHI, et al.

Filed: September 25, 2001

For: SEMICONDUCTOR DEVICE HAVING WIRES AND INSULATOR LAYERS WITH VIA-STUDS

CLAIM FOR PRIORITY

Assistant Commissioner for Patents
Washington, D.C. 20231

September 25, 2001

Sir:

Pursuant to the provisions of 35 USC §119 and 37 CFR §1.55, Applicants hereby claim the right of priority based on Japanese Patent Application No. 10-143133, filed in Japan on May 25, 1998.

A certified copy of the above-referred-to Japanese Patent Application was submitted in prior application Serial No. 09/317,955, filed May 25, 1999, on May 25, 1999.

Respectfully submitted,

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